

IN THE SPECIFICATION:

The paragraph beginning at line 17 of page 1 has been amended as follows:

Up to now, various optical deflection apparatuses in which a mirror is resonated have been proposed. As compared with a light-scanning optical system using a rotary polygonal mirror such as a polygon mirror, a resonance type optical deflection apparatus has the features that the size of the optical deflection apparatus can be significantly reduced; power consumption is small because a Q value is high; there is theoretically no optical ~~face angle~~ facet angle error; an optical deflection apparatus made of single-crystalline Si manufactured by particularly a semiconductor process theoretically has no metal fatigue and excellent durability (see Japanese Patent Application Laid-Open No. S57-008520).